## Accepted Manuscript

Controlled synthesis of hierarchical nanoflake structure of NiO thin film for supercapacitor application

Girish S. Gund, C.D. Lokhande, Ho Seok Park

PII: S0925-8388(18)30167-1

DOI: 10.1016/j.jallcom.2018.01.166

Reference: JALCOM 44630

To appear in: Journal of Alloys and Compounds

Received Date: 23 September 2017

Revised Date: 9 January 2018

Accepted Date: 12 January 2018

Please cite this article as: G.S. Gund, C.D. Lokhande, H.S. Park, Controlled synthesis of hierarchical nanoflake structure of NiO thin film for supercapacitor application, *Journal of Alloys and Compounds* (2018), doi: 10.1016/j.jallcom.2018.01.166.

This is a PDF file of an unedited manuscript that has been accepted for publication. As a service to our customers we are providing this early version of the manuscript. The manuscript will undergo copyediting, typesetting, and review of the resulting proof before it is published in its final form. Please note that during the production process errors may be discovered which could affect the content, and all legal disclaimers that apply to the journal pertain.



## Controlled Synthesis of Hierarchical Nanoflake Structure of

## NiO Thin Film for Supercapacitor Application

Girish S. Gund<sup>a</sup>, C. D. Lokhande<sup>b,c</sup>, Ho Seok Park<sup>a</sup>

## **Graphical Abstract**





Download English Version:

https://daneshyari.com/en/article/7993567

Download Persian Version:

https://daneshyari.com/article/7993567

Daneshyari.com